12-7-01   A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BOX PATENT APPLICATION
COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

24197

Transmitted herewith for filing is the patent application of:

Inventor(s): Jin Udagawa

For: DEVICES AND METHODS FOR MONITORING RESPECTIVE OPERATING
        TEMPERATURES OF COMPONENTS IN A MICROLITHOGRAPHY APPARATUS

Enclosed are:

⊠   14 pages of specification, 5 pages of claims, an abstract and a Combined
     Declaration and Power of Attorney (unsigned).

⊠   3 sheet(s) of drawings.

⊠   A certified copy of a Japan Patent Application No. 2000-366847, filed December
     1, 2000.

| FILING FEE | | | | | |
For	Claims Filed	Number Free	Number Extra	Rate	Basic Fee $740.00
Total Claims	20	20 =	0	$18.00	$ 0.00
Independent Claims	3	3 =	0	$84.00	$ 0.00
Multiple Dependent Claim Fee				$280.00	
TOTAL FILING FEE					$740.00

⊠   Applicant claims the benefit under 35 U.S.C. § 119 of the earlier filing date of foreign
     application number 2000-366847, filed on December 1, 2000.

⊠   Assignee for this application is or will be Nikon Corporation, and applicant requests that
     this information be listed on the published application.

⊠   A check in the amount of $740.00 to cover ⊠ filing fee and ☐ assignment recordal fee
     is enclosed.
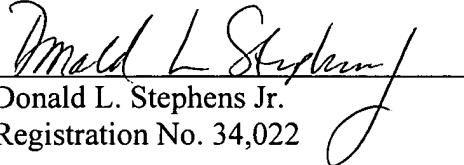
☒   The Director is hereby authorized to charge any additional fees that may be required in connection with the filing of this application and recording any assignment filed herewith, or credit over-payment, to Account No. 02-4550. A copy of this sheet is enclosed.

☒   Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

By   _Donald L. Stephens Jr._ (signature)
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